

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,170,683 B2
APPLICATION NO. : 10/510725
DATED : January 30, 2007
INVENTOR(S) : Minoru Sugawara

Page 1 of 1

It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Title Page:

Item (54) should be read as follows:

-- REFLECTOR FOR EXPOSURE LIGHT AND ITS MANUFACTURE METHOD,
MASK, EXPOSURE APPARATUS AND SEMICONDUCTOR DEVICE
MANUFACTURE METHOD --.

Signed and Sealed this

Seventh Day of August, 2007

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a distinct "D" at the end.

JON W. DUDAS

Director of the United States Patent and Trademark Office